PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No: O81612

In re application of

Hisayuki MIKI, et al. Appln, No.: 10/585,999 Group Art Unit: 2814 Confirmation No.: 1177 Examiner: Eva MONTALVO Filed: July 13, 2006 For: P-TYPE GROUP III NITRIDE SEMICONDUCTOR AND PRODUCTION METHOD THEREOF AMENDMENT UNDER 37 C.F.R. § 1.111 MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir: In response to the Office Action dated February 2, 2009, please amend the aboveidentified application as follows on the accompanying pages. Since May 2, 2009 fell on a Saturday, the filing of the Amendment on Monday, May 4, 2009 is timely. TABLE OF CONTENTS AMENDMENTS TO THE CLAIMS......2

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